Electronic Acknowledgement Receipt				
EFS ID:	2489201			
Application Number:	10512405			
International Application Number:				
Confirmation Number:	4607			
Title of Invention:	High resistance silicon wafer and its manufacturing method			
First Named Inventor/Applicant Name:	Nobumitsu Takase			
Customer Number:	25227			
Filer:	Adam Keser/Kathleen Libby			
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Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.
		47.000000 K	342025	yes	9
1		4740820028.pdf	9b9daa2ea23483ee0det314a327fb7ac 41db1003		
	Multipa	rt Description/PDF files in	zip description		
	Document Description		Start	End	
	Miscellaneous Incoming Letter		1	1	
	Extension of Time		2	2	
	Amendment - After Non-Final Rejection		3	3	
	Claims		4	6	
	Applicant Arguments/Remarks Made in an Amendment		7	9	
Warnings:					
Information:					
2 Fee Worksheet (PTO-06)	fee-info.pdf	8179	no	2	
	ree Worksheet (F1O-00)	iee-illio.pdi	1boda7b78250b7411804678238117o43 1e5a40a7	110	
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## New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

## National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/IOO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filling Receipt, in due course.

## New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.